



Docket No. 194378US-2 CONT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Tetsuo TANIGUCHI

GAU: 2851

SERIAL NO: 09/618,550

EXAMINER: NGUYEN, H.

FILED: JULY 17, 2000

FOR: EXPOSURE METHOD AND LITHOGRAPHY SYSTEM, EXPOSURE APPARATUS AND METHOD OF MAKING THE APPARATUS, AND METHOD OF MANUFACTURING DEVICE

**REQUEST FOR EXTENSION OF TIME
UNDER 37 C.F.R. 1.136**

ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

SIR:

It is hereby requested that a two month extension of time be granted to **AUGUST 21, 2002** for

- ☒ filing a response to the Official Action dated: MARCH 21, 2002
- ☐ responding to the requirements in the Notice of Allowability dated:
- ☐ filing the Formal Drawings. The Issue Fee due has been timely filed.
- ☐ responding to the Notice to File Missing Parts of Application dated:
- ☐ filing a Notice of Appeal. A timely response to the final rejection, due has been filed.
- ☐ filing an Appeal Brief. A Notice of Appeal was filed on:
- ☐ Applicant claims small entity status. See 37 CFR 1.27. Therefore, the fee amount shown below is reduced by one-half.

The required fee of **\$400.00** is enclosed herewith by check and any further charges may be made against the Attorney of Record's Deposit Account No. **15-0030**. A duplicate copy of this sheet is enclosed.

08/22/2002 SZEWDIE1 00000005 09618550

01 FD:116

400.00 DP

Respectfully Submitted,

OBLON, SPIVAK, McCLELLAND,
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Jm.